Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the

application:

Listing of Claims:

1. (currently amended) A method, comprising:

applying a laser beam to a layer of first material including a bottom surface

disposed on a layer of second material, wherein the laser beam penetrates beyond the

first material and into the second material, to diffuse a portion of the first material into

the second material, wherein the laser beam penetrates beyond the first material and

into the second material, to form an alloy, wherein the alloy is formed entirely below the

bottom surface of the layer of first material.

2. (previously presented) The method of claim 1, wherein:

the laser beam is provided by one of a YAG laser, a CO2 laser, or an infrared

laser.

3. (previously presented) The method of claim 1 wherein:

the second material includes metal; and

applying the laser beam forms an electrically conductive trace.

4. (previously presented) The method of claim 3, wherein:

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the first material includes tin, the second material includes copper, and the electrically conductive trace includes a copper tin alloy.

5. (previously presented) The method of claim 3, wherein:

the laser beam has a width between about 2 mils and about 8 mils.

6-10 (cancelled)

11. (currently amended) A method comprising:

forming a metal layer on a core;

placing a diffusion layer on the metal layer; and

applying photo-thermal energy via laser beam to the diffusion layer to diffuse a portion of the diffusion layer into the metal layer, wherein the laser beam penetrates beyond the diffusion layer and into the metal layer; and

removing non-diffused portions of the diffusion layer by chemical mechanical polishing.

12-27 (cancelled)

28. (previously presented) The method of claim 1, wherein:

the laser beam causes a portion of the second material to ablate into a plasma.

29. (previously presented) The method of claim 1, wherein:

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the laser beam is provided by a laser programmed to pattern a desired pattern of electrically conductive traces.

- 30. (previously presented) The method of claim 3, further comprising: removing non-diffused portions of the layer of first material.
- 31. (previously presented) The method of claim 11, wherein:

the metal layer comprises copper and the diffusion layer comprises at least one of an organic material, a polymer epoxy, or an organic metal.

- 32. (canceled)
- 33. (previously presented) The method of claim 30, wherein:
 removing non-diffused portions of the layer of first material comprises chemical mechanical polishing.
- 34. (previously presented) The method of claim 30, wherein:

forming the electrically conductive trace comprises forming the electrically conductive trace with a 20%-30% larger width than a desired width, the desired width being obtained after removing non-diffused portions of the layer of first material.

35. (new) The method of claim 11, further comprising: removing non-diffused portions of the metal layer.

36. (new) The method of claim 11, wherein:the metal layer includes copper and the diffusion layer includes tin.